

United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE

BIBDATASHEET

Bib Data Sheet

CONFIRMATION NO. 8557

			_				
SERIAL NUMBER 10/645,911	FILING DATE 08/22/2003		CLASS 134	GROUP ART UNIT 1746		ATTORNEY DOCKET NO. 047297-0137	
APPLICANTS							
Hisatsugu Kurita, Shibata-shi, JAPAN;							
Manabu Hirasawa, Shibata-shi, JAPAN; Hiromi Nagahama, Shibata-shi, JAPAN;Koji Izumome, Shibata-shi, JAPAN; Takao Ino, Yokohama-shi, JAPAN; Jyunsei Yamabe, Yokohama-shi, JAPAN; Naoya Hayamizu, Yokohama-shi, JAPAN; Naoaki Sakurai, Yokohama-shi, JAPAN;							
CONTINUING DATA MK (NONE)							
FOREIGN APPLICATIONS ************************************							
Foreign Priority claimed	№ □		<u> </u>	<u> </u>	<u></u>	-	·
35 USC 119 (a-d) conditions	yes no no Met aft	er	STATE OR	SHEETS	TOTA	L	INDEPENDENT
Verified and	Allowance /	1C tials	COUNTRY JAPAN	DRAWING 7	CLAIM 4	IS	CLAIMS 1
ADDRESS 22428 FOLEY AND LARDNE SUITE 500 3000 K STREET NW WASHINGTON, DC 20007	R						
TITLE Silicon wafer cleaning	method						